

**RECEIVED  
CENTRAL FAX CENTER**

**AUG 15 2005**

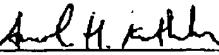
S/N 10/682,229

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	TABARA	Examiner:	Goudreau, George
Serial No.:	10/682,229	Group Art Unit:	1763
Filed:	October 8, 2003	Docket No.:	12844.0045US01
Title:	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE		

**CERTIFICATE UNDER 37 CFR 1.8:** The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service, as first class mail, with sufficient postage, in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 15, 2005

By:   
Name: Anol H. Kavathekar

**AMENDMENT & RESPONSE**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450



Dear Sir:

In response to the Office Action mailed April 15, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.